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OTPETO TRADEMARK

APPLIED MATERIALS

2881 Scott Blvd. M/S 2061, Santa Clara, CA 95050



LEGAL DEPARTMENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Steven VERHAVERBEKE, et al

Assignee:

APPLIED MATERIALS, INC.

Title:

METHOD AND APPARATUS FOR WAFER CLEANING

Serial No.:

9/891,849

Confirmation Number Assignment: 4749

Filed:

06/25/2001

Group Art Unit: 1746

Attorney Docket No.: 004711/P01

Examiner: MARKOFF, Alexander

Santa Clara, California October 17, 2003

## RESPONSE TO RESTRICTION REQUIREMENT UNDER 37 C.F.R. 1.143

Hon. Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

The present communication is in response to the Office Action dated October 10, 2003, outlining the Examiner's restriction requirement between the following groups:

- Claims 1-25, 45, 46, 52-56 and 105-108, drawn to an apparatus, classified in class
   134, subclass 184.
- 11. Claims 26-44 and 47-50, drawn to a method, classified in class 134, subclass 1.3.